

## ENABLER OVERVIEW

### Who should attend?

This course is designed for those individuals in the semiconductor industry who require an overview of the Centura AP Enabler system.

### Course Benefits

Provide technical foundation necessary to work effectively with Applied Materials equipment.

Provide understanding of equipment function, operation, and basic process application for Applied Materials equipment.

### Course Objectives

- Understand the main components of the Centura AP Enabler: mainframe and chambers, user interface and workstation, and remote support equipment.

### Course Modules

1. *Introduction*
2. *System Overview*
3. *Safety*
4. *Chamber*
5. *Factory Interface*
6. *Single-wafer Loadlock*
7. *Transfer Chamber*
8. *Control System*
9. *Electrical System*
10. *Gas Systems*
11. *Vacuum System*
12. *Cooling System*

### Registration Information

**Prerequisites:** *None*

**Course Length:** *2.5 Hours*

**Course Type:** *Web-based Training*

**Course Number:** *TRNWEB-99*

To enroll or for more information on our products and services, please call our registrar at one of the numbers below or go to [www.appliedtraining.com](http://www.appliedtraining.com).

- 1-800-468-8888, option 4 (United States)
- 1-512-272-0027 (International)

### Computer System Requirements:

Attending this course requires a Windows 98, NT, 2000 or XP computer using Internet Explorer 5.5 or higher. 128MB RAM or higher and high-speed Internet access is also highly recommended